

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Hiroki SATO et al.

Conf. 6778

Application No. 10/588,187

Group 1792

Filed August 2, 2006

Examiner E. Burkhart

ALKOXIDE COMPOUND, MATERIAL FOR THIN FILM FORMATION,
AND PROCESS FOR THIN FILM FORMATION

AMENDMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 15, 2009

Sir:

In response to the Office Action mailed August 17,
2009, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing
of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.